

	Application No.	Applicant(s)
Notice of Allowability	09/852,994 Examiner	SCHMIDT ET AL. Art Unit
,	Lamine	
<u> </u>	Quyen P. Leung	2828
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this or other appropriate communical IGHTS. This application is subject	application. If not included tion will be mailed in due course. THIS
1. This communication is responsive to 3/5/2004.		
2. X The allowed claim(s) is/are 1,2,4-7,10 and 14-18.		
3. The drawings filed on 10 May 2001 are accepted by the Ex	kaminer.	•
 4. ☐ Acknowledgment is made of a claim for foreign priority unallocation. a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No	·,
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a replENT of this application.	oly complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subminification (PTO-152) which give	itted. Note the attached EXAMINI es reason(s) why the oath or deck	ER'S AMENDMENT or NOTICE OF aration is deficient.
6. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.	
(a) including changes required by the Notice of Draftspers		O-948) attached
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the	e Office action of
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	.84(c)) should be written on the dra ne header according to 37 CFR 1.12	wings in the front (not the back) of 21(d).
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I 	sit of BIOLOGICAL MATERIA FOR THE DEPOSIT OF BIOLOG	L must be submitted. Note the ICAL MATERIAL.
Attachment(s)		
1. Notice of References Cited (PTO-892)	5. Notice of Informa	l Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summa	
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0		ndment/Comment
4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's State 9. □ Other	Quyen P. Leung Primary Examiner Art Unit: 2828

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) Application/Control Number: 09/852,994 Page 2

Art Unit: 2828

REASONS FOR ALLOWANCE

In response to applicant's after final amendment filed 3/5/2004, claims 1, 4, 5, 6,
 14 have been amended, claims 3, 9, 11-13 canceled and claims 15-18 added.

Claims 1-2, 4-7, 10, 14-18 are pending and allowed.

2. The following is an examiner's statement of reasons for allowance: the cited prior art do not teach or fairly suggest a semiconductor ridge waveguide laser diode including a limiting means comprising an isolation layer whose lateral extension is wider than the laser's waveguide ridge but smaller than the metallization's lateral extension.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quyen P. Leung whose telephone number is (571)272-1943. The examiner can normally be reached on 9-5:30, M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on (571)272-1834. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 09/852,994

Art Unit: 2828

Page 3

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Quyen P. Leung Primary Examiner Art Unit 2828

QPL